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# Strain relaxation in monolayer MoS<sub>2</sub> over flexible substrate†

Nilanjan Basu, (10 ‡ ab Ravindra Kumar, ‡ ab D. Manikandan, abc Madhura Ghosh Dastidar, abd Praveen Hedge, ad Pramoda K. Nayak (10 \*\*abce\*) and Vidya Praveen Bhallamudi\*\*

In this communication, we demonstrate uniaxial strain relaxation in monolayer (1L)  $MoS_2$  transpires through cracks in both single and double-grain flakes. Chemical vapour deposition (CVD) grown 1L  $MoS_2$  has been transferred onto polyethylene terephthalate (PET) and poly(dimethylsiloxane) (PDMS) substrates for low (~1%) and high (1–6%) strain measurements. Both Raman and photoluminescence (PL) spectroscopy revealed strain relaxation *via* cracks in the strain regime of 4–6%. *In situ* optical micrographs show the formation of large micron-scale cracks along the strain axis and *ex situ* atomic force microscopy (AFM) images reveal the formation of smaller lateral cracks due to the strain relaxation. Finite element simulation has been employed to estimate the applied strain efficiency as well as to simulate the strain distribution for  $MoS_2$  flakes. The present study reveals the uniaxial strain relaxation mechanism in 1L  $MoS_2$  and paves the way for exploring strain relaxation in other transition metal dichalcogenides (TMDCs) as well as their heterostructures.

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### 1. Introduction

TMDCs are considered to be an exciting class of layered materials.<sup>1-4</sup> One layer of a TMDC comprises X–M–X stacking, where X is a chalcogen and M is a metal atom. Across many applications of this type of two-dimensional (2D) material, strain engineering is becoming prominent. The effect of strain on 2D materials has a multifold effect on their surface morphology and properties. Strain can give rise to wrinkles, cracks, and interlayer dislocations in 2D materials including TMDCs. Strain modulation in TMDCs has been well reported in the literature, with reports available for both uniaxial and biaxial strain modulation in 2D materials/TMDCs like MoS<sub>2</sub>, WSe<sub>2</sub>, WSe<sub>2</sub>, MoSe<sub>2</sub>, MoTe<sub>2</sub>, and many more.<sup>5-9</sup> TMDCs show very small bending rigidity and a high Young's modulus, which makes them the perfect choice for bendable electronics.<sup>10,11</sup> In

addition, strain is also important for other applications such as single photon emission, optoelectronics, wearable electronics, piezoelectric sensors and moiré pattern studies. <sup>12-15</sup> The study of strain relaxation and strain threshold over the transfer characteristics of MoS<sub>2</sub> and other TMDCs is particularly important for flexible electronics where a lot of repeated deformation takes place. For these applications, it is crucial to identify the strain regime where strain relaxation starts to appear and its associated mechanisms. However, such studies in TMDCs are in a nascent stage.

Strain can be introduced in TMDCs in multiple ways, which can be classified into two broad categories such as *in situ* synthesis and post-synthesis. During the *in situ*-synthesis process, strain can be generated by exploiting the lattice and thermal expansion coefficient mismatch between the substrate and the as-grown TMDCs. <sup>16-18</sup> Whereas, the post-synthesis process is carried out by transferring the as-grown 2D material over flexible, patterned, and piezoelectric substrates for strain generation. <sup>19-22</sup> Strain is also generated during the wet transfer process due to the formation of bubbles at the interface between the 2D material and substrate. <sup>23</sup>

Raman and PL spectroscopy are the two major nondestructive tools for studying strain modulation. The in-plane Raman mode in a TMDC is more sensitive to uniaxial strain compared to the out-of-plane mode. The shift in the in-plane Raman is due to the anharmonicity of the molecular potential.<sup>24</sup> Several studies have focussed on band gap modulation and direct to the indirect transition of band gap with the applied strain in low regime (0–1%).<sup>25,26</sup> For both low and high

<sup>&</sup>lt;sup>a</sup>Department of Physics, Indian Institute of Technology Madras, Chennai 600 036, India. E-mail: pramoda.iitm@gmail.com; praveen.bhallamudi@iitm.ac.in

<sup>&</sup>lt;sup>b</sup>2D Materials Research and Innovation Group, Indian Institute of Technology Madras, Chennai 600 036. India

<sup>&</sup>lt;sup>e</sup>Micro Nano and Bio-Fluidics Group, Indian Institute of Technology Madras, Chennai 600 036 India

<sup>&</sup>lt;sup>4</sup>Quantum Center of Excellence for Diamond and Emerging Materials (QuCenDiEM) Group, Departments of Physics and Electrical Engineering, Indian Institute of Technology Madras, Chennai 600036, India

<sup>&</sup>lt;sup>e</sup>Centre for Nano and Material Sciences, Jain (Deemed-to-be University), Jain Global Campus, Kanakapura, Bangalore, Karnataka 562112, India

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 $<sup>\</sup>ddagger$  Equally contributed to the work.

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strain regimes, the band gap decreases linearly with the increase in strain. The behavior of the Raman phonon mode and PL spectra in a high-strain regime has also been reported and shows the signature of strain relaxation after a certain point.<sup>27,28</sup> Molybdenum disulphide (MoS<sub>2</sub>) is an interesting and well-studied member of the TMDC family. The odd layer of MoS<sub>2</sub> exhibits broken inversion symmetry and shows one of the highest piezo responses in monolayer TMDCs. 29,30 This property propels for application in strain sensing, piezotronics, flexible optoelectronics, and nanocomposites.31,32 These applications inevitably require a comprehensive understanding of the strain effect over the band structure of MoS2 and also about strain relaxation mechanisms. In 2018 Niehues et al. reported the effect of strain (0-1.6%) over polycrystalline CVD grown MoS2 and studied the strain transfer process across the grain boundaries.33 Apart from this, there are substantial number of reports currently available about strain engineering in single layer MoS2 over flexible substrates, but only a hand full of publications report about strain relaxation mechanism in MoS<sub>2</sub>. <sup>27,34,35</sup> Nevertheless, there is still a considerable research gap in the strain relaxation mechanism and identification of the strain regime where relaxation starts. In this present work, we have investigated the strain relaxation process of monolayer CVD grown single and double grain MoS2 flakes transferred onto flexible substrates like PET and PDMS, and highlighted the role of cracks during strain-relaxation. Finite element simulation has been carried out to estimate the strain efficiency of both the flexible substrates and the strain distribution of MoS<sub>2</sub> flakes over them.

#### Results and discussion 2.

#### 2.1. Strain modulation

CVD-grown monolayer MoS2 flakes on (SiO2/Si) substrate is transferred over 125 µm thick PET substrate for strain modulation in 0-1% strain regime. The strain measurement has been carried out similar to that reported in ref. 36 and has been discussed in the ESI (Fig. S1).† Fig. 1(a) shows the optical micrograph of the as grown MoS2 on SiO2/Si substrate (monolayer characterization has been given in Fig. S2†). Fig. 1(b and c) shows the PL and Raman spectra of the transferred 1L MoS2 over PET under a low strain (0 to 0.82%). The PL spectra show that there is a gradual red shift, which implies the reduction of the direct band gap with the increase in strain (Fig. 1(e)). The linear fit in Fig. 1(e) gives a modulation efficiency of 52 meV/%, which is in agreement with the reported literature for monolayer  $MoS_2$ .<sup>37</sup> The shift in the optical band gap with strain is due to the increase in the valence band maxima position, although the conduction band minima position remains stable.<sup>38</sup> The inplane mode  $(E_{2g}^1)$  in the Raman spectra (Fig. 1(b)) also shows a gradual red shift. The out-of-plane mode  $(A_{1g})$  is less sensitive to the applied uniaxial strain. The in-plane mode shows a redshift of 4.67 cm<sup>-1</sup>/% strain and the out-of-plane mode shows a much smaller redshift of 0.848 cm<sup>-1</sup>/%, which is consistent with the literature.<sup>25</sup> As the applied strain is in-plane in nature, the  $E_{2g}^1$  mode is more sensitive to the in-plane strain compared to the  $A_{1g}$  mode. Both the PL and Raman spectra and

in situ optical micrograph (shown in Fig. S2(c)†) do not show any signature of strain relaxation.

In order to study this effect, a further increase in strain has been achieved by transferring 1L MoS2 over a 2 mm thick flexible PDMS substrate. For this study, a monolayer double grain butterfly like MoS<sub>2</sub> flake has been chosen. Fig. 2(a) and (b) shows the PL and Raman spectra of monolayer MoS2 over PDMS under 0 to 6.2% strain. The absence of B exciton in the PL spectra can be attributed to the fact that the polymers substrates used to generate strain inhibits the B exciton intensity, which is analogous to other reports. 39-41 The ex situ optical image of the particular double grain butterfly like flake (after application of strain) is shown in Fig. 2(c). The PL and Raman shift  $(E_{2g}^1)$  with strain is shown in Fig. 2(a and b). The PL spectra with strain variation show a red shift up to 3.85% strain and on further increasing the strain, a blue shift is observed. This blue shift gradually continues up to 5.52% and 6.2% compared to the A exciton peak at 0% strain. The MoS<sub>2</sub> film is completely relaxed at 6.2%.

The Raman spectra of the butterfly shaped flake also show strain relaxation but at a slightly different strain value. After a gradual red shift up to 4.4% strain, the E<sub>2g</sub> peak undergoes a blue shift at 5.52% strain indicating the relaxation process. There is a slight difference of  $\sim$ 1% strain between the strain relaxation point in PL and Raman spectra, which can be attributed to the fact that the electronic band structure is more sensitive to the applied strain than lattice vibrational modes. Apart from the double grain flake, the effect of strain over single grain triangular flake has also been investigated (Fig. S3†). The single grain triangular flake also behaves in a similar manner to the double grain flake, as shown in Fig. 2(c).

The strain relaxation commences at 4.4% strain for both the morphologies and this strain regime for the strain relaxation of monolayer MoS2 well matches in accordance with recent literature (Fig. 3).27 It has been reported that breaking occurs at 6-11% strain for a suspended monolayer exfoliated MoS2, which is slightly higher than our result.42 This difference can be attributed to the effect of the polymer substrate. Although the relaxation starts at a similar strain for both the flakes, the triangular flake attains a relaxed state at a lower strain than the double grain flake. The defects, vacancy states, dislocations, and structural imperfections of the MoS2 film also affect the strain relaxation process. Further focused studies are required to identify these effects and to establish a correlation between them (Fig. 3).

Fig. 4(a) shows the in situ optical micrograph (recorded during PL & Raman measurement at 4.4% strain) and Fig. 4(b) shows ex situ (recorded after application of strain) atomic force microscopy (AFM) image. The grain boundary can be clearly seen in the AFM image. The distinctly visible cracks in the optical micrographs indicate that the strain relaxation is actuated by the formation of cracks in the MoS<sub>2</sub> film. Owing to the limited resolution of the optical microscope, only the large cracks along the strain axis are visible. A closer inspection with AFM shows that other small lateral wrinkles also formed during the relaxation process. Wrinkle formation is also evident in triangular flakes as shown in Fig. S4.† Fig. 4(c) shows the height

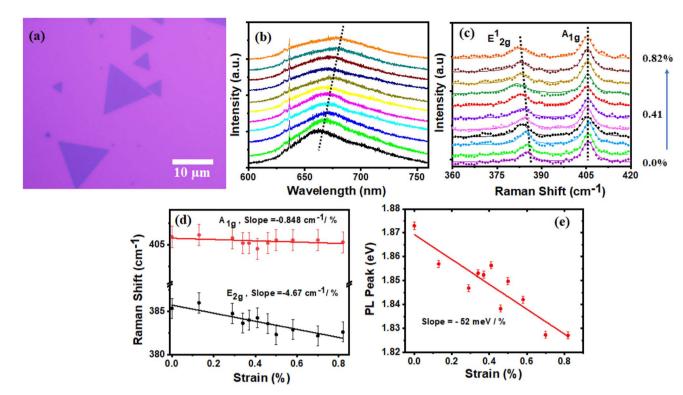


Fig. 1 Raman, PL spectra under strain over PET. Optical micrograph (a) of as-synthesized 1L MoS<sub>2</sub> over SiO<sub>2</sub>/Si, (b) and (c) PL & Raman spectra of 1L MoS<sub>2</sub> under low strain over PET. (d) and (e) Raman & PL peak shift with respect to the strain percentage.

profile through a wrinkle of the double-grain flake, which shows a height of 17 nm. Wrinkles with variable sizes starting from 4 nm to as large as 26 nm are observed (Fig. S4†). Cracks and wrinkles of similar dimensions have also been reported in WS<sub>2</sub> as the mode of strain relaxation.<sup>28</sup> The AFM images (both Fig. 4 and S4†) have been recorded under relaxed conditions after the application of strain. The wrinkles displayed in the images indicate that there is a permanent change in the surface morphology of the MoS<sub>2</sub> flakes. Cracks are also observed during the synthesis process of polycrystalline MoS<sub>2</sub> and MoSe<sub>2</sub> and MoSe<sub>2</sub> alloy as a way of strain relaxation during the synthesis

process.<sup>33,35</sup> For our as synthesized MoS<sub>2</sub> flakes over SiO<sub>2</sub>/Si substrate, we have not observed any cracks (Fig. S2†). Generally, cracks and grain boundaries are more common in a polycrystalline MoS<sub>2</sub> film. When subjected to strain a polycrystalline film with cracks exhibits a similar PL shift to that of a single grain flake.<sup>33</sup> This is because each crack behaves as an independent edge and strain propagation is almost seamless across cracks. Despite this similarity, as synthesized film with cracks is not suitable for strain relaxation studies. As cracks already present in the film make it difficult to study strain relaxation in a controlled way.

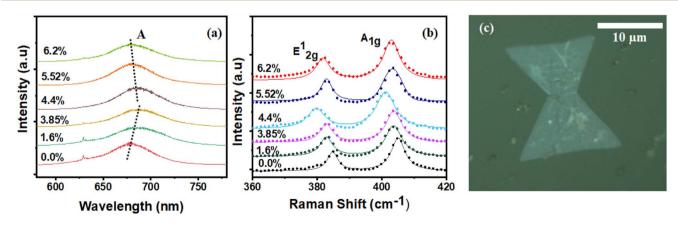


Fig. 2 Raman and PL spectra under strain over PDMS. (a) PL spectra of  $1L MoS_2$  under strain over 2 mm thick PDMS. (b) Raman spectra of the same flake under strain (c) ex situ optical micrograph of the particular flake after strain modulation.

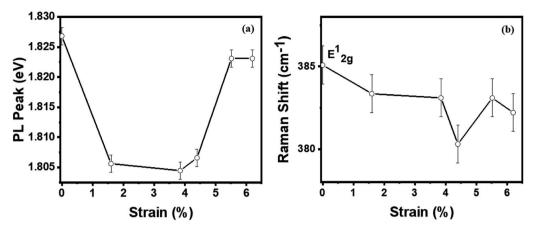


Fig. 3 PL peak shift vs. strain (a) and Raman peak shift vs. strain (b) of the double grain MoS<sub>2</sub> flake.

#### 2.2. Finite element simulation

Further, to understand the strain transfer efficiency of the substrate, we have carried out the finite element simulations using COMSOL Multiphysics 6.0 (see Methods section). The schematic diagram of the MoS<sub>2</sub> flakes transferred over the PDMS substrate used in our simulations is shown in Fig. 5(a). Fig. 5(b and c) shows the strain distribution on the MoS<sub>2</sub> flakes (both single and double grain) for the three different applied strains on the PDMS substrate. Because of the significant difference in the Young's modulus values of the substrate and flake, the strain distribution is not uniform, and a small amount of strain is transferred to the flakes (Fig. 5(d)) similar to that reported in earlier studies. <sup>28,31,32,37,38,41,43</sup>

The strain distribution on the flake depends on the orientation and its size. The double-grain flake shows more transferred strain than the single flake due to its large area of contact with the PDMS substrate. Fig. S6† shows the strain distribution on the  $MoS_2$  flakes for the different strains over PET substrate. We observe the uniform distribution of the strain throughout

the flake, and also,  $\sim$ 97% of the applied strain is transferred to the flakes. To get more insights into the strain transfer efficiency of the substrate, we performed additional simulations by varying the substrate's Young's modulus value. The results show that the transfer efficiency follows sigmoidal variation with Young's modulus (Fig. 5(e)). Also, using the substrate with Young's modulus in the same order as that of the flake can result in an efficient strain transfer (more than 90%). 8,25,26,28

## 3. Methods

#### 3.1. Materials and growth

Witec alpha 300 Raman spectrometer was used for acquiring all Raman and PL spectra with a grating of 1800 lines per mm and a  $50\times$  objective (0.7 NA) with a spot size of  $\sim$ 1  $\mu$ m. The resolution of the Raman spectrometer was 1.3 cm $^{-1}$  and the applied power was 3.5 mW. For all the spectra, the excitation wavelength was 532 nm. The Lorentzian function was used for fitting the Raman plots. To measure the thickness of the flakes Park systems NX10 AFM was used, with a tip radius less than 10 nm,

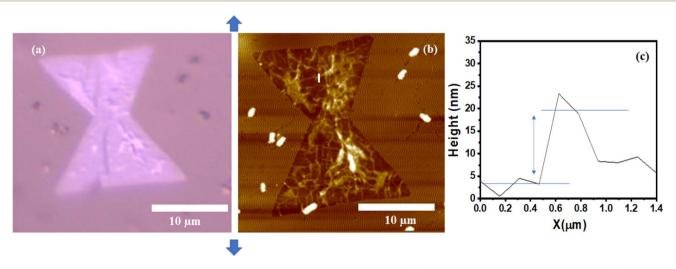


Fig. 4 AFM and optical micrograph of the double grain flake. In situ optical micrograph (a) of the  $MoS_2$  flake under 4.4% strain and (b) ex situ AFM of the flake over PDMS. (c) The height profile of the wrinkle (in (b), shown by a white line) shows 17 nm height. The arrows indicate the strain axis.

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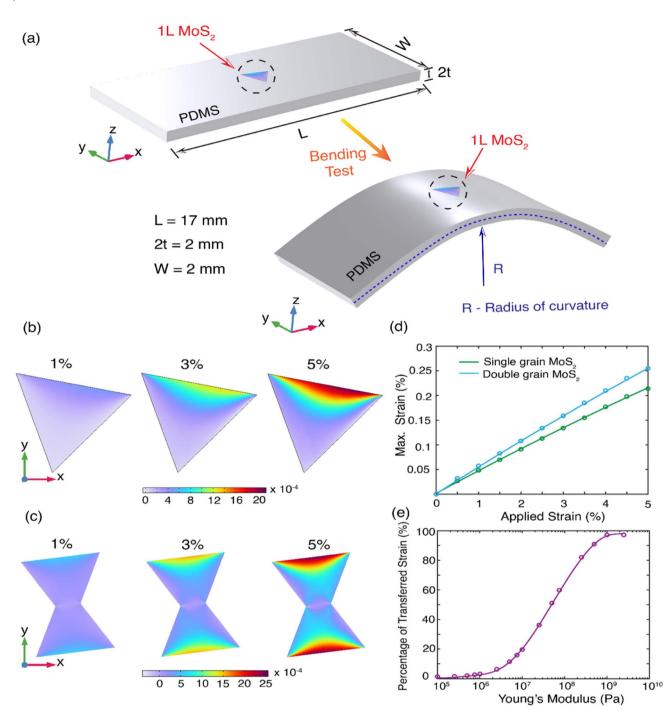


Fig. 5 Finite element simulation of 1L MoS<sub>2</sub> over PDMS. (a) Schematics of the 1L MoS<sub>2</sub> deposited on the PDMS substrate before and after bending. The strain distribution on single grain (b) and double grain (c) 1L MoS<sub>2</sub> for the applied strain of 1%, 3%, and 5%, respectively. (d) Maximum strain observed on the  $MoS_2$  vs. applied strain on the PDMS. (e) Percentage of transferred strain vs. Young's modulus of substrate.

force constant of 42 N m<sup>-1</sup>, and 330 kHz frequency. The AFM micrographs were recorded in non-contact mode. The optical micrographs were recorded by using a Nikon Eclipse LV100ND microscope.

Single layer MoS2 was grown over 290 nm SiO2/Si in a twozone atmospheric pressure CVD (APCVD). Sulphur (Sigma Aldrich, 99.98%) and molybdenum(w) oxide (Alfa Aesar, 99%) was used as a precursor. 4 mg MoO3 was kept in an alumina

crucible in the middle of zone one (825 °C) and 315 mg S was kept 35 cm upstream in zone two (285 °C). 100 SCCM Ar was used as a carrier gas and also for purging (15 min). The SiO<sub>2</sub>/Si was cleaned in acetone, isopropyl alcohol, and deionized water before loading into the growth chamber. Growth was carried out for 45 min in the presence of Ar atmosphere.

#### 3.2. Transfer, strain measurement and simulation

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The as-grown 1L MoS<sub>2</sub> was transferred over PET/PDMS by using a wet transfer method. As 5 M KOH solution was used as an etchant and 3% polymethyl methacrylate (PMMA) was used as the top coating (spin-coated at 4000 rpm). Once transferred over PET/PDMS, the PMMA/MoS<sub>2</sub> was air dried for 36 hours to reduce the chances of wrinkle formation. Finally, hot acetone (60 °C) was used to remove the top PMMA layer. A single axis micro stage with a resolution of 10  $\mu$ m was used to bend the PET/PDMS (shown in Fig. S1†). The radius of curvature (R) and the thickness (2t) of PET/PDMS was used to calculate the generated strain.

The finite element simulations of MoS<sub>2</sub> (both single and double grain) flakes on PDMS/PET substrate were performed using COMSOL Multiphysics 6.0 software. Fig. 5(a) shows the schematic diagram of the MoS<sub>2</sub> flake on the PDMS substrate before/under bending. Appropriate boundary conditions were applied to the substrate for simulating the 3-point bending. The perfect bonding condition is assumed between the substrate and the MoS<sub>2</sub> flake. The complete system is discretized into 274 897 to 550 861 elements and the results reported are independent of mesh. Material properties used in these simulations are given in Table S1.†<sup>45-48</sup>

## 4. Conclusion

The strain transfer efficiency is high for PET, but we did not observe any strain relaxation of the flakes in the case of PET substrate for the applied strain. In contrast, the MoS<sub>2</sub> flake goes through strain relaxation on the PDMS substrate. As the calculated strain transfer efficiency is poor for the PDMS substrate with respect to its Young modulus, we used a thicker PDMS film (2 mm thick, Fig. S1†) to generate a strain of 6%. We attribute the strain relaxation to the formation of the wrinkles and cracks on the flakes due to the significant difference in Young's modulus of the substrate and flakes.28,41 The formation of wrinkles on the flakes affects their ultimate tensile strength resulting in the cracking of the flakes. From finite element simulations, it is evident that the crack of the flakes starts at the location where maximum strain is observed and propagates towards the gradient of strain inside the flakes (Fig. 4, 5 and S3†). However, the formation of the wrinkles on the flakes is entirely random.

In summary, a series of uniaxial strain modulation studies were performed over mono layer single and double-grain MoS<sub>2</sub>. The applied strain varied from 0–6.2%, in which PET substrate was used for a low strain regime and PDMS for a higher strain regime. Our results show that monolayer MoS<sub>2</sub> displays signs of strain relaxation between 4 to 6% strain. Further *in situ* optical micrographs and *ex situ* AFM images show that the relaxation is accompanied by the formation of cracks. These cracks formed both along the strain axis and also perpendicular to the strain axis. The applied strain in monolayer MoS<sub>2</sub> relaxes by forming cracks. 3D finite element simulations were also performed, which showed that the Young modulus of the flexible substrate plays an important role in the strain transfer efficiency between

the  $MoS_2$  flake and substrate. Also, the simulated propagation direction of the cracks well matched the experimental results. The authors hope that this work would provide a comprehensive understanding of the strain relaxation mechanism and strain threshold in  $MoS_2$  and that this study can be extended to other TMDCs as well.

#### Author contributions

Nilanjan Basu performed the growth, experiments and characterization, analyzed the data and wrote the manuscript. Ravindra Kumar performed experiments, Madhura Ghosh Dastidar and Praveen Hedge performed characterization. D. Manikandan did the simulation and wrote manuscript. Pramoda K. Nayak and Vidya Praveen Bhallamudi provided helpful discussions and reviewed the manuscript. All authors have given approval to the final version of the manuscript.

## Conflicts of interest

The authors declare no conflict of interest.

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